

**Notice of References Cited**

Application/Control No.

10/538,023

Applicant(s)/Patent Under  
Reexamination  
IWAKUMA ET AL.

Examiner

MICHAEL E. NELSON

Art Unit

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Page 1 of 1

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	B	US-			
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	D	US-			
	E	US-			
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	I	US-			
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	K	US-			
	L	US-			
	M	US-			

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	O	JP 2002008860	01-2002	Japan	Sato et al.	
	P	JP 2003031371	01-2003	Japan	Sato et al.	
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**NON-PATENT DOCUMENTS**

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	V	Machine Translation of JP 2002008860. (01-2002)
	W	Machine Translation of JP 2003031371. (01-2003)
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